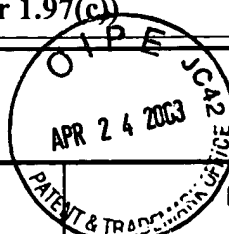


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<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))			Docket No. Q106-US1	
In Re Application Of: Hisashi Tsukam to et al.				
Serial No. 10/031,022	Filing Date January 14, 2002	Examiner N/A	Group Art Unit 1734	
<p>Title:</p> <p><b>LITHIUM THIN FILM LAMINATION TECHNOLOGY ON ELECTRODE TO INCREASE BATTERY CAPACITY</b></p>				
<p>Address to:</p> <p>Assistant Commissioner for Patents Washington, D.C. 20231</p>				
<p><b>37 CFR 1.97(b)</b></p> <p>1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.</p>				
<p><b>37 CFR 1.97(c)</b></p> <p>2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:</p> <p style="margin-left: 40px;"><input type="checkbox"/> the statement specified in 37 CFR 1.97(e);</p> <p style="text-align: center; margin-left: 100px;"><b>OR</b></p> <p style="margin-left: 40px;"><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).</p>				



**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
Q106-US1

In Re Application: Hisashi Tsukamoto et al.

Serial No.  
10/031,022

Filing Date  
January 14, 2002

Examiner  
N/A

Group Art Unit  
1734

LITHIUM THIN FILM LAMINATION TECHNOLOGY ON ELECTRODE TO INCREASE BATTERY CAPACITY

**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-0921 as described below. A duplicate copy of this sheet is enclosed.
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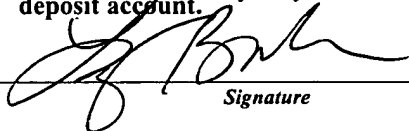
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Dated: 4-24-03

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